



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Nicholas A. WARD et al.

Serial No. 09/927,444

Filed: August 13, 2001

For: Dynamic Control Of Wafer Processing Paths In
Semiconductor Manufacturing Processes

:
:
:
:
: Group Art Unit: 2125
:
: Examiner: Sean P. Shechtman

RECEIVED

JUL 16 2004

Technology Center 2100

PETITION FOR EXTENSION OF TIME

Honorable Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated January 20, 2004 for three months, from April 20, 2004 to July 20, 2004.

Please charge the \$950.00 fee to cover the cost of the extension to Deposit Account No. 08-0219. Any deficiency or overpayment should be charged or credited to Deposit Account No. 08-0219.

Respectfully submitted,

Wilmer Cutler Pickering Hale and Dorr LLP

Anthony H. Kahng
Registration No. 42,704

The Willard Office Building
1455 Pennsylvania Avenue, NW
Washington, DC 20004
202 942 8400

Date: July 13, 2004

07/15/2004 BABRAHA1 00000147 080219 09927444

01 FC:1253 950.00 DA